

03500.015462.



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

#7 / IDS
1-23-02
R. Stohr

In re Application of:)	Examiner: Not Yet Assigned
KIYOTAKA WASA ET AL.)	
Application No.: 09/880,757)	Group Art Unit: 2812
Filed: June 15, 2001)	
For: STRUCTURE OF PIEZOELECTRIC)	
ELEMENT AND LIQUID)	
DISCHARGE RECORDING HEAD,)	
AND METHOD OF)	
MANUFACTURE THEREFOR)	January 17, 2002

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JAN 22 2002
TC 2800 MAIL ROOM

Commissioner for Patents
Washington, D.C. 20231

INFORMATION DISCLOSURE STATEMENT.

Sir:

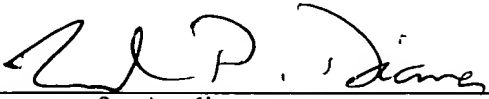
In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the document listed on the enclosed Form PTO-1449. A copy of the listed document is also enclosed.

The listed document is the English translation of the Japanese article "Sputtering Technologies" cited in the Information Disclosure Statement filed on October 31, 2001 in the above-identified patent application.

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,


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